

Notice of References Cited	Application/Control No. 10/525,443	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner Elizabeth Burkhart	Art Unit 1792	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Sasaki et al, Iron pyrite thin film prepared by double source vacuum vapor deposition, Journal of Materials Science Letters 18 (1999), p. 1193-1195.
	V	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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